



00862.022168

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Seiji TAKEUCHI et al.) : Examiner: A. Kosowski
Application No.: 09/819,670) : Group Art Unit: 2125
Filed: March 29, 2001) : Confirmation No.: 3161
For: STOCKER, EXPOSURE APPARATUS,) : January 29, 2004
DEVICE MANUFACTURING METHOD,) :
SEMICONDUCTOR MANUFACTURING)
FACTORY, AND EXPOSURE APPARATUS :
MAINTENANCE METHOD)

15/D
C.A.
2/4/04

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED

JAN 30 2004
Technology Center 2100

AMENDMENT

Sir:

In response to the Official Action dated October 29, 2003, please amend the above-identified application as follows: